

In the United States Patent and Trademark Office

Appn. Number: \_\_\_\_\_

Appn. Filed: \_\_\_\_\_

Applicant(s): Herzinger et al.

Appn. Title: ODD BOUNCE IMAGE ROTATION SYSTEM IN ELLIPSO METER SYSTEM

Examiner/GAU: \_\_\_\_\_ /324

Mailed: With Application

At: \_\_\_\_\_



#2  
21 Nov 01  
R. Tallier

Information Disclosure Statement

Commissioner of Patents and Trademarks  
Washington, District of Columbia 20231

Sir:

Attached is a completed Form PTO-1449 and copies of the pertinent parts of the references cited thereon.

Following are comments on these references pursuant to Rule 98:

IDENTIFIED PATENTS

Patent to Herzinger, No. 6,137,618 is disclosed as it describes a Single Brewster Angle Polarizer in the context of multiple reflecting means, and discloses prior art dual Brewster Angle Single Reflective Means Polarizer Systems.

Patent to Herzinger et al., No. 6,084,675 describes an adjustable beam alignment compensator/retarder with application to spectroscopic ellipsometry.

Patent No. 6,118,537 to Johs et al. describes a multiple Berek plate optical retarder system.

Patent No. 6,141,102 to Johs et al. describes a single triangular shaped optical retarder element.

Patent No. 5,946,098 to Johs et al., describes dual tipped wire grid polarizers in combination with various compensator/retarder systems.

Patent No. 6,100,981 to Johs et al., describes a dual Horizontally oriented triangular shaped optical retarder.

Patent No. 6,084,674 to Johs et al., describes a parallelogram shaped optical retarder element.

Patent No. 5,963,325 to Johs et al., describes a dual vertically oriented triangular shaped optical retarder element.

A Patent to Johs et al., No. 5,872,630 is disclosed as it describes an ellipsometer system in which an analyzer and polarizer are maintained in a fixed in position during data acquisition, while a compensator is caused to continuously rotate.

A Patent to Thompson et al. No. 5,706,212 is also disclosed as it teaches a mathematical regression based double Fourier series ellipsometer calibration procedure for application, primarily, in calibrating ellipsometers system utilized in infrared wavelength range. Bi-refrigent, transmissive window-like compensators are described as present in the system thereof, and discussion of correlation of retardations entered by sequentially adjacent elements which do not rotate with respect to one another during data acquisition is described therein.

Further Patents of which the Inventor is aware include:

Nos. 5,757,494; and  
5,956,145;

to Green et al., in which are taught a method for extending the range of Rotating Analyzer/Polarizer ellipsometer systems to allow measurement of DELTA'S near zero (0.0) and one-hundred-eighty (180) degrees, and the extension of modulator element ellipsometers to PSI'S of forty-five (45) degrees. Said Patents describes the presence of a variable, transmissive, bi-refrigent component which is added, and the application thereof during data acquisition to enable the identified capability.

Patent to He et al., No. 5,963,327 is disclosed as it describes an ellipsometer system which enables providing a polarized beam of electromagnetic radiation at an oblique angle-of-incidence to a sample system in a small spot area.

Patents of general interest of which the Inventor is aware include:

Patent to Woollam et al, No. 5,373,359;  
Patent to Johs et al. No. 5,666,201;  
Patent to Green et al., No. 5,521,706; and  
Patent to Johs et al., No. 5,504,582;

and are disclosed as they pertain to ellipsometer systems.

Patent to Coates et al., No. 4,826,321 is disclosed as it describes applying a reflected monochromatic beam of plane polarized electromagnetic radiation at a Brewster angle of incidence to a sample substrate to determine the thickness of a thin film thereupon. This Patent also describes calibration utilizing two sample substrates, which have different depths of surface coating.

Other Patents which describe use of reflected electromagnetic radiation to investigate sample systems are:

Nos. RE 34,783,  
4,373,817,  
5,045,704 to Coates; and  
5,452,091 to Johnson.

Patent to Bjork et al., No. 4,647,207 is disclosed as it describes an ellipsometer system which has provision for sequentially positioning a plurality of reflective polarization state modifiers in a beam of electromagnetic radiation.

Patent Nos.

4,210,401;  
4,332,476; and  
4,355,903

are also identified as being cited in the 207 Patent. It is noted that systems as disclosed in these Patents, (particularly in the 476 Patent), which utilize reflection from an element to modify a polarization state.

Patent to Mansuripur et al., No. 4,838,695 is disclosed as it describes an apparatus for measuring reflectivity.

Patents to Rosencwaig et al., Nos.

4,750,822; and  
5,595,406

are also identified as they describe systems which impinge electromagnetic beams onto sample systems at oblique angles of incidence. The 406 Patent provides for use of multiple wavelengths and multiple angles of incidence. For similar reasons Patent No.

5,042,951

to Gold et al. is also disclosed.

In addition to the identified Patents, certain Scientific papers are also identified.

A paper by Johs, titled "Regression Calibration Method for Rotating Element Ellipsometers", Thin Solid Films, 234 (1993) is also disclosed as it describes a mathematical regression based approach to calibrating ellipsometer systems.

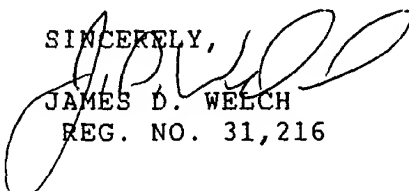
A paper by Smith, titled "An Automated Scanning Ellipsometer", Surface Science, Vol. 56, No. 1. (1976), is also mentioned as it describes an ellipsometer system which does not require any

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moving, (eg. rotating), elements during data acquisition.

A review paper by Collins, titled "Automatic Rotating Element Ellipsometers: Calibration, Operation and Real-Time Applications", Rev. Sci. Instrum., 61(8) (1990).

SINCERELY,



JAMES D. WELCH

REG. NO. 31,216

**LIST OF PRIOR ART CITED BY APPLICANT**  
(Use several sheets if necessary)

APPLICANT

FILING DATE

GROUP

Hertinger et al.

879 U.S. PTO  
09/26/01  
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**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FIGING IF APPROPRIATE
AA	6137618	10/2000	Hertinger	359	245	
AB	6084675	7/2000	Hertinger et al.	356	369	
AC	6118537	9/2000	Johs et al.	356	369	
AD	6141102	10/2000	Johs et al.	356	364	
AE	5946098	8/1999	Johs et al.	356	364	
AF	6106981	8/2000	Johs et al.	356	364	
AG	6084674	7/2000	Johs et al.	356	364	
AH	5963325	10/1999	Johs et al.	356	364	
AI	5872630	2/1999	Johs et al.	356	369	
AJ	5706212	1/1998	Thompson et al.	364	525	
AK	5757494	5/1998	Green et al.	356	369	

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
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**OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

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Hertzinger et al.

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	5956145	9/1999	Green et al.	356	364	
AB	5963327	10/1999	He et al.	356	369	
AC	5373359	12/1994	Woolham et al.	356	328	
AD	5666201	9/1997	Johr et al.	356	369	
AE	5521706	5/1996	Green et al.	356	369	
AF	5504582	4/1996	Johr et al.	356	369	
AG	4826321	5/1989	Coater et al.	356	351	
AH	RE34783	11/1994	Coater	250	372	
AI	4373817	2/1983	Coater	356	384	
AJ	5045704	9/1991	Coater	250	372	
AK	5452091	9/1995	Johnson	356	445	

## FOREIGN PATENT DOCUMENTS

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(Use several sheets if necessary)APPLICANT Hertzinger

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## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	4647207	3/1987	Bjork et al	356	369	
AB	4210401	7/1980	Batten	356	369	
AC	4332476	7/1982	Stenberg et al.	356	369	
AD	4355903	10/1982	Sandrock	356	382	
AE	4838695	7/1989	Manrurpur et al.	356	369	
AF	4750822	7/1988	Rosenchwaig et al.	356	445	
AG	5596406	1/1997	Rosenchwaig et al.	356	327	
AH	5042951	8/1991	Gald et al.	356	369	
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Hertinger et al.

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"Regression Calibration Method for Rotating Element  
Ellipsometers", Johs, Thin Solid Films, 234 (1993).

"An Automated Scanning Ellipsometer", Smith, Surface Science,  
Vol. 56, No. 1. (1976).

"Automatic Rotating Element Ellipsometers: Calibration, Operation  
and Real-Time Applications", Collins, Rev. Sci. Instrum., 61(8)  
(1990).

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